

Docket No.: 50023-164



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tatsumi WATANABE, et al.

Serial No.:

Group Art Unit:

Filed: January 18, 2002

Examiner:

For:

IMAGE PROCESSING METHOD AND IMAGE PROCESSING APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Serial No.:

The relevance of each non-English language reference, if any, is discussed in the present specification.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: January 22, 2002 Facsimile: (202) 756-8087

SHEET <u>1</u> OF <u>1</u>

INFORMATION DISCLOSURE CITATION IN AN APPLICATION				ATTY. DOCKET NO. 50023-164		SERIAL NO.		.s. Pro 1124	
				APPLICANT Tatsumi WA	ranabi	E, et al.		10/05	
(PTO-1449)				FILING DATE January 18, 2002		GROUP		j	
		U	.S. PATEN	T DOCUMENTS					
EXAMINER'S INITIALS				NAME		SUBCLASS	FILING DATE		
		FOR	EIGN PAT	ENT DOCUMEN	ITS		Т	ranslation	
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY		CLASS	SUBCLASS	Yes	No	
	1-264092	10/20/1989	Japan (w/ English Abstract)						
	2539361	7/8/1996	Japan (w/ H	English Abstract)	<u> </u>				
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	OTHE	R ART (Incl	iding Autho	or, Title, Date, Per	rtinent P	ages, Etc.)	LL		
EXAMINE	ξ			DATE CONSIDE	RED				

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.